CA SERIES **ROUNDNESS & CYLINDRICITY**













FUNCTION

It can measure the roundness (column), straightness, runout, full runout, taper, diameter, concentricity, coaxiality, flatness, parallelism, perpendicularity, eccentricity, etc. of various regular and irregular annular workpieces Analyzed surface waviness (Wc, Wp, Wv, Wt, Wa, Wq), spectrum analysis, wave height analysis

DATA ANALYSIS AND PROCESSING

Spectrum analysis: analyze the amplitude of different frequency components Removal of abnormal data: remove abnormal data manually or automatically, such as burrs, holes and bulges

File management: survey data auto save database

Result printing: it can be used for regular printing or exported to PDF file

	itom	Model			
item		CA30	CA65	CA95	
measuring range	Maximum workpiece rotation diameter	ф320mm	ф420mm	φ420mm	
	Maximum measuring height	300mm	400mm	500mm	
	Maximum measuring depth	Use standard probe: 100mm (when the aperture is less than 36mm); The maximum measurable diameter of non-standard support is 300mm (optional if the aperture is greater than 36mm)			
	Maximum bearing capacity	25Kg	50Kg	100Kg	
Air floating spindle	Axial error of spindle	± (0.025+0.0005H/) μm 🔆	± (0.015+0.0003H) μm	± (0.0125+0.0003H) μm	
	Radial error of spindle	± (0.025+0.0006X) μm 🔆	± (0.0125+0.0004X) µm	± (0.02+0.0004X) μm	
workbench	Table diameter	φ150mm	ф200mm	φ200mm	
	Adjustment range	Centering ± 3mm; Leveling ± 1 °			
Straightness		0.5µm/100mm	0.4µm/	0.4µm/100mm	
Parallelism of rotation axis and Z-axis guide rail		1.5µm/300mm	2µm/400mm	2.5µm/500mm	
Horizontal stroke		250mm		270mm	
Sensor	Range	500µm (Radius difference)			
	Probe shape	φ2mm Gem ball probe (Optional φ 1mm、 φ 0.5mm measuring probe)			

The parameters in the table above are default configurations.

If other configurations are required, they can be selected according to the order number

ROUNDNESS FILTERING SECTION

1-500、1-150 1-50、1-15、15-500

WAVINESS FILTER BAND

3–16、17–100

ROUNDNESS **EVALUATION METHOD**

Minimum area method, least square method Minimum circumscribed circle method, maximum inscribed circle method

TECHNICAL PARAMETER

* H: Measuring height from the table, X: Measuring radius